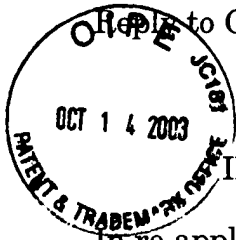


Appl. No. 09/816,643  
Amdt. Dated October 10, 2003  
Reply to Office Action of April 10, 2003

Attorney Docket No. 81877.0012  
Customer No.: 26021



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Seiyo Nakashima et al.

Serial No: 09/816,643

Confirmation No.: 6862

Filed: March 23, 2001

For: SUBSTRATE PROCESSING  
APPARATUS AND SUBSTRATE  
PROCESSING METHOD

Art Unit: 1763

Examiner: Kackar, Ram N

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**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated April 10, 2003, the time for response to which is extended three month by the accompanying petition to October 20, 2003, please amend the above-referenced application as follows:

**Amendments to the Claims begin on page 2 of this paper.**

**Remarks/Arguments begin on page 10 of this paper.**

10/20/2003 MBIZUNES 00000074 09816643

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